

Sviluppo di un fotomoltiplicatore a valanga basato su giunzione nanotubi di carbonio/Si

**SCAPho-Silicon Carbon Avalanche
Photodetector**

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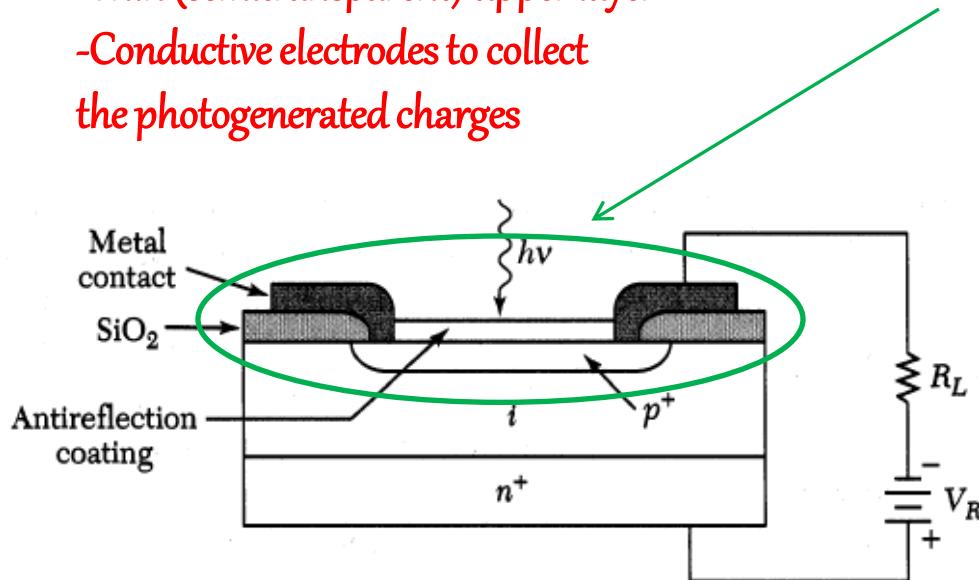
Collaborations

Fondazione Bruno Kessler Trento-Italy
ISM-CNR Frascati-Italy

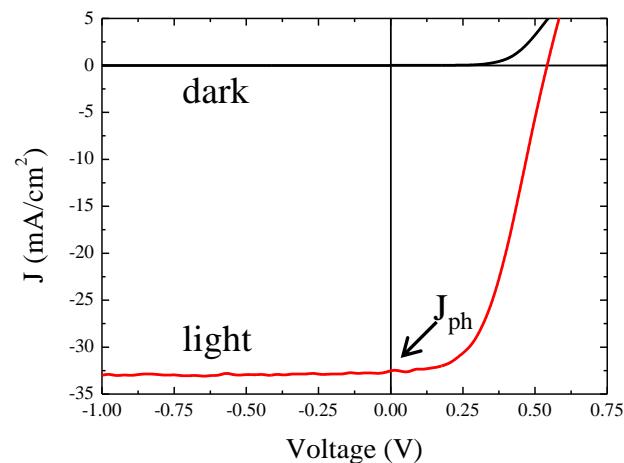
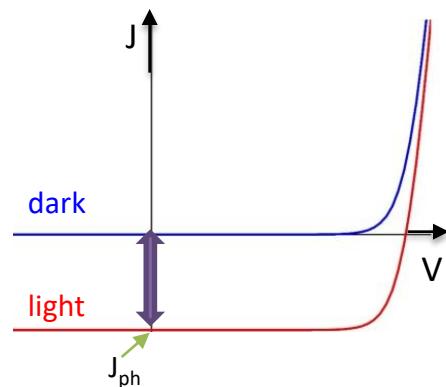
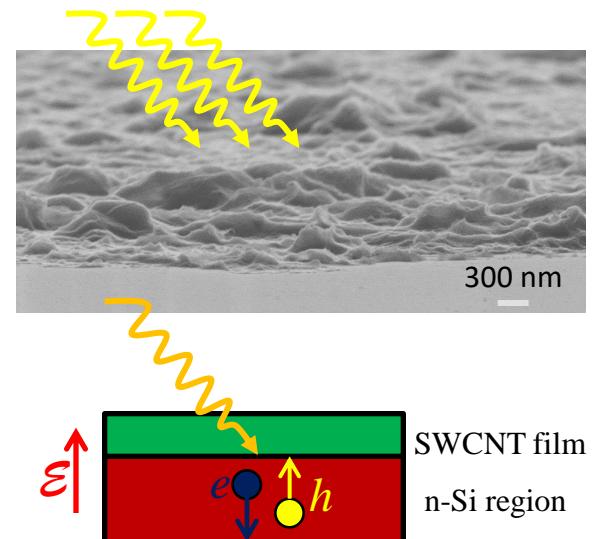
Photodetectors

p-n semiconducting or metal Schottky junction

- Antireflection coating
- Thin (semitransparent) upper layer
- Conductive electrodes to collect the photogenerated charges

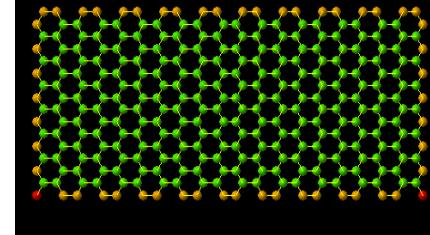
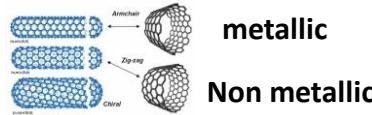


Substitution with a Single Walled Carbon Nanotube (SWCNT) thin film



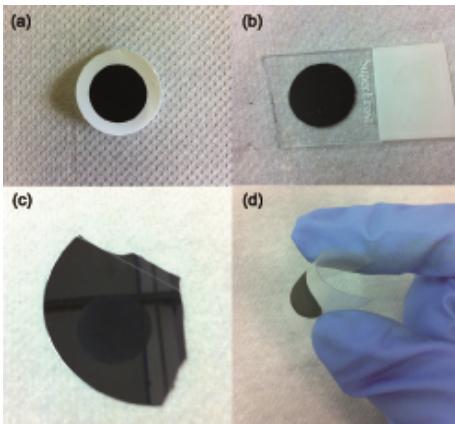
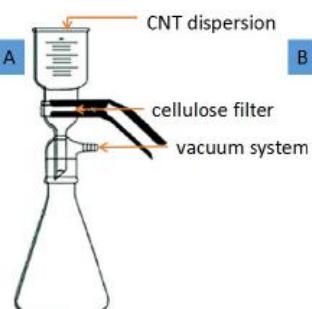
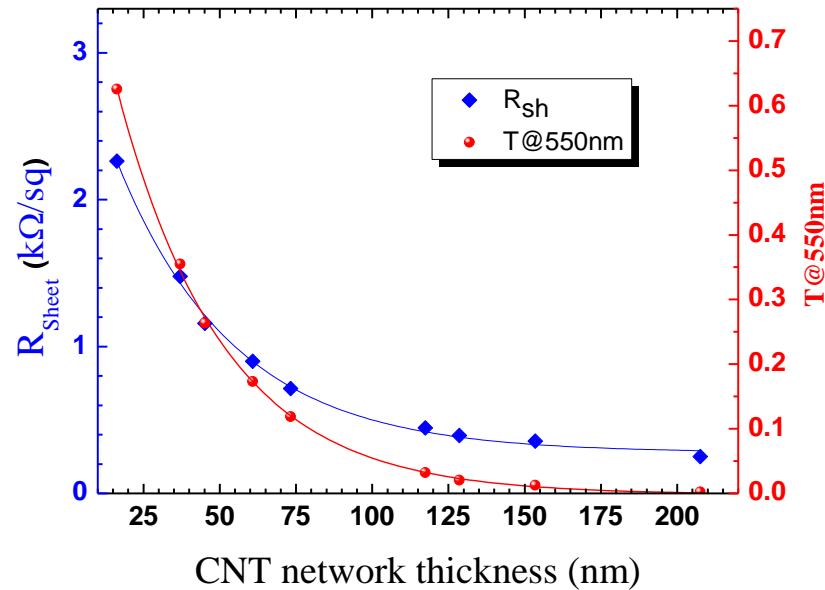
1-
Low-cost
Rapid
Room-temperature process
Versatile deposition method
Scalable technique
Highly reproducible
SWCNT random networks

Realization and properties of CNT films



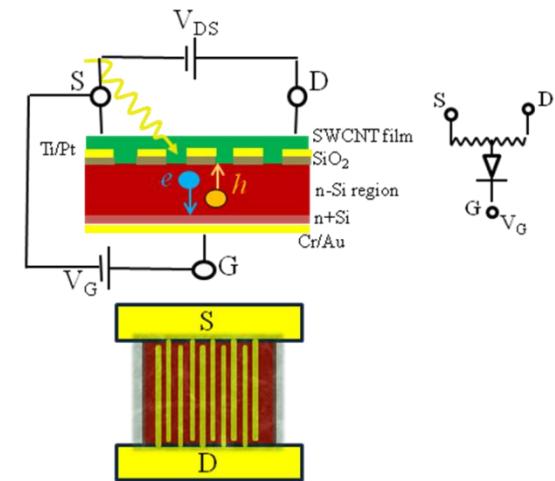
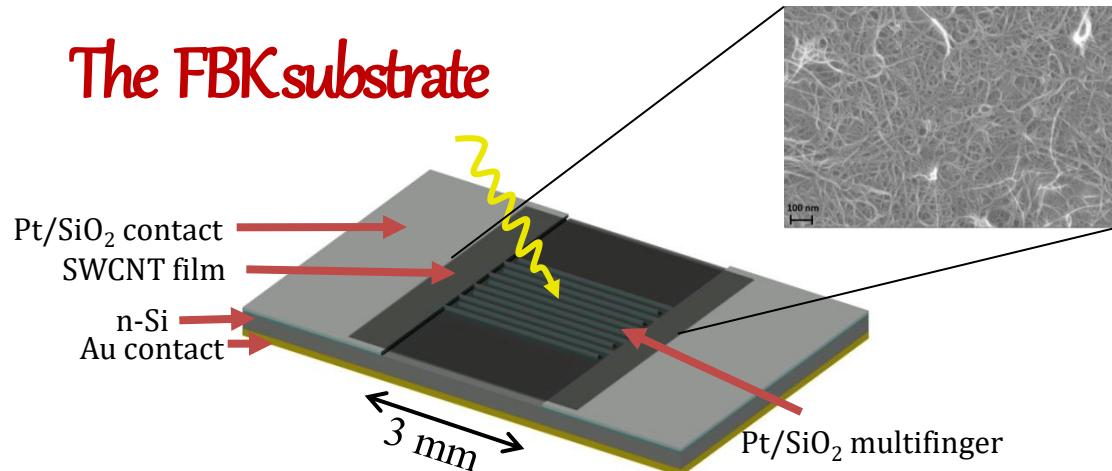
2- SWCNT thin films are conductive and semitransparent

Optical transmittance and electrical conductivity are two competing parameters both depending on the film thickness and the metallic CNT concentration

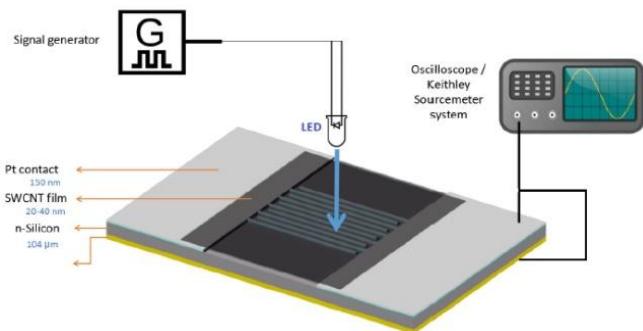


The SWCNT/n-Si device

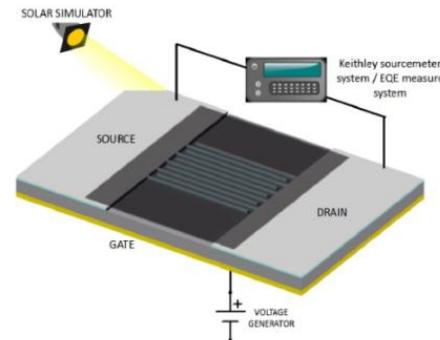
The FBK substrate



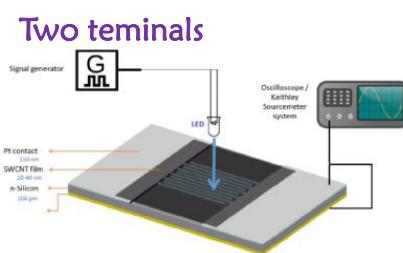
Two possible configurations for two and three terminal measurements



Two terminals



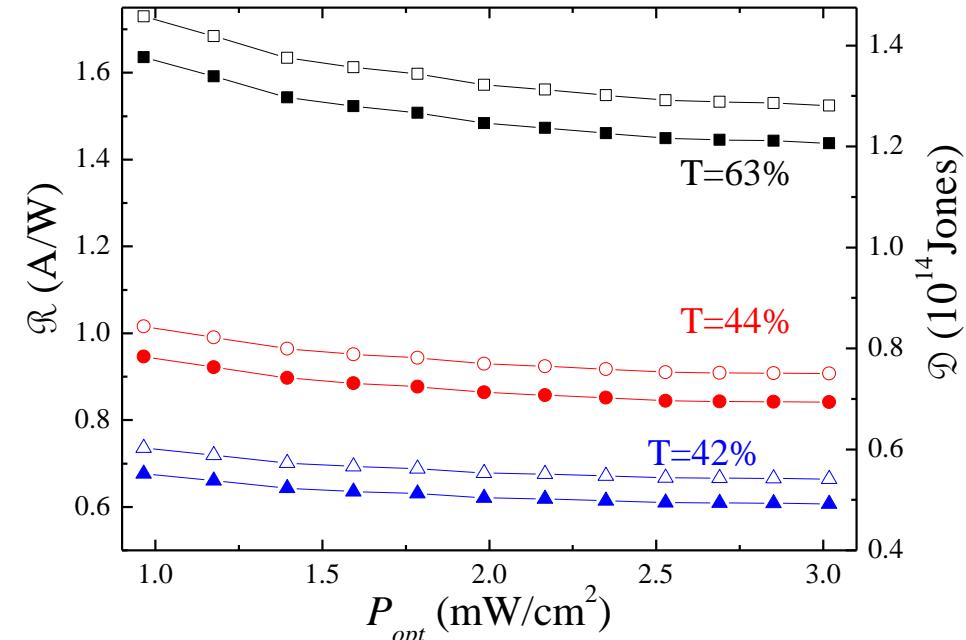
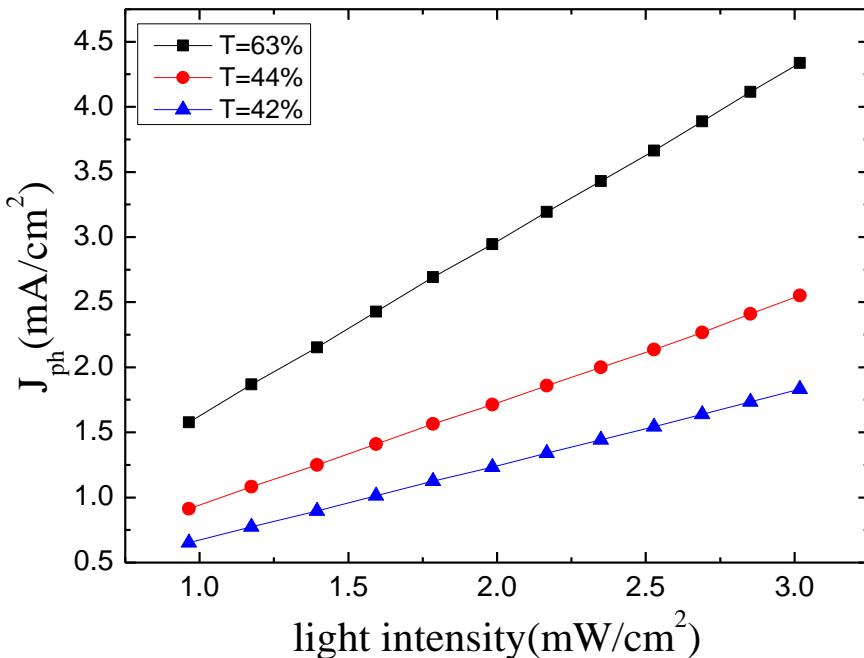
Three terminals



Main results of SWCNT/Si photodetectors



Linearity with the incident power density
High responsivity and detectivity



$$J_{ph} \propto P_{in}$$

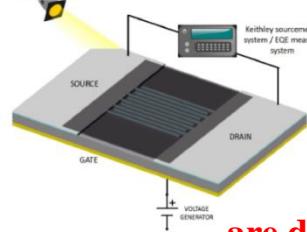
$$\mathcal{R} = \frac{I_{ph} - I_0}{P_{opt}}$$

The Responsivity measures the PD input-output gain

$$\mathcal{D} = \sqrt{\frac{A}{2eI_0}} \mathcal{R}$$

The Detectivity measures the ability of a PD to detect small signals

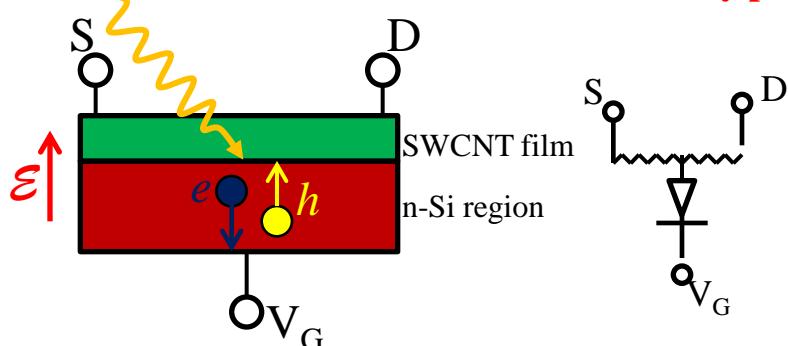
Three terminals



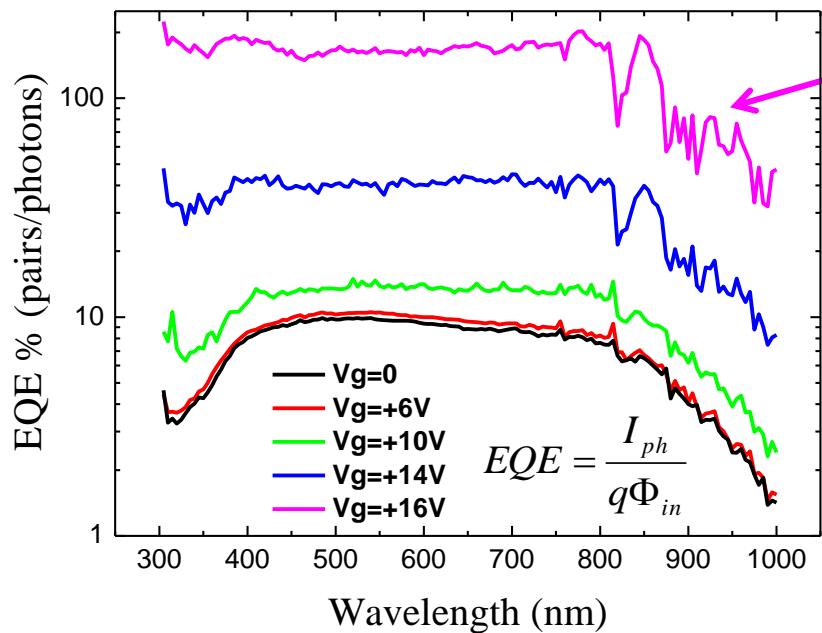
Three terminals measurements

AVALANCE PHOTODETECTOR

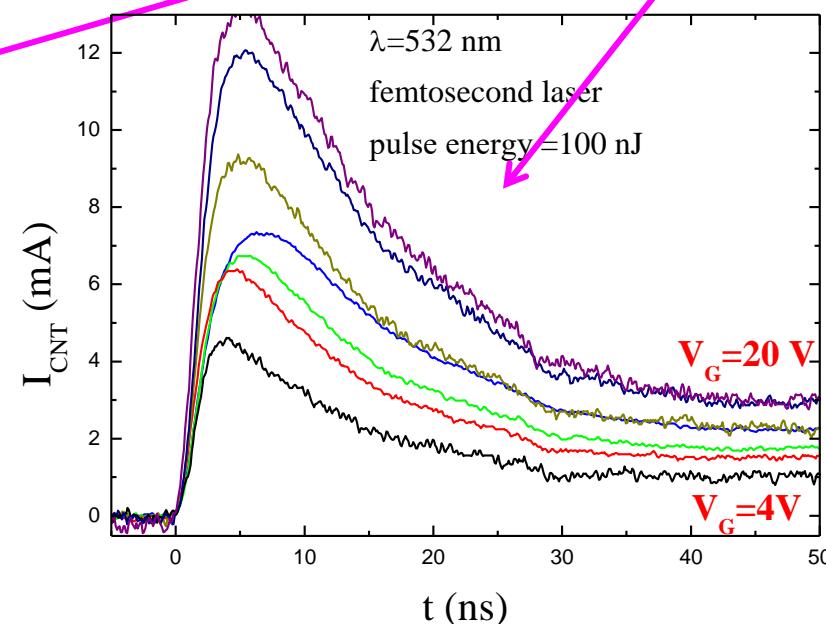
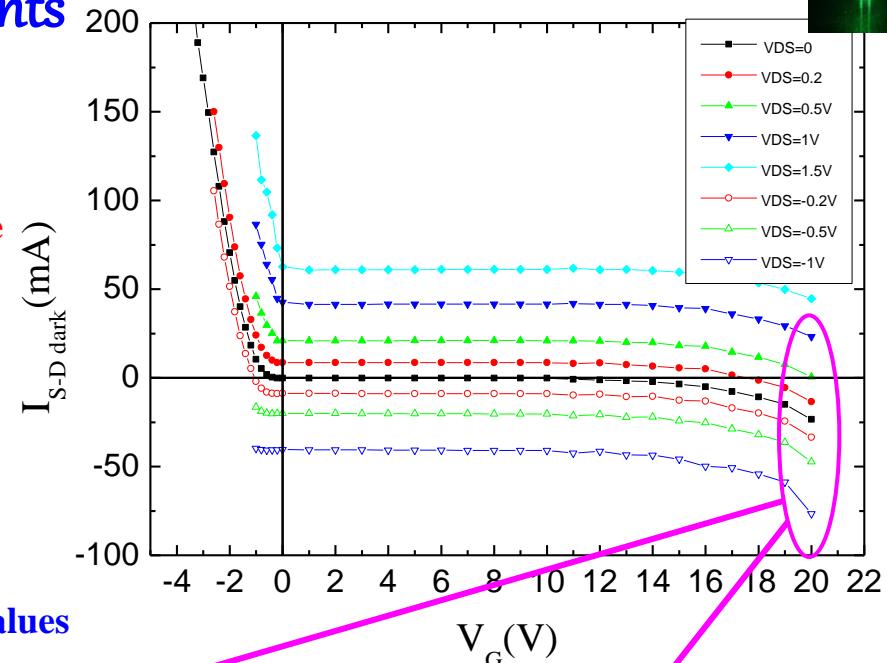
Photogenerated charges inside Si
are drifted toward SWCNT film by positive gate



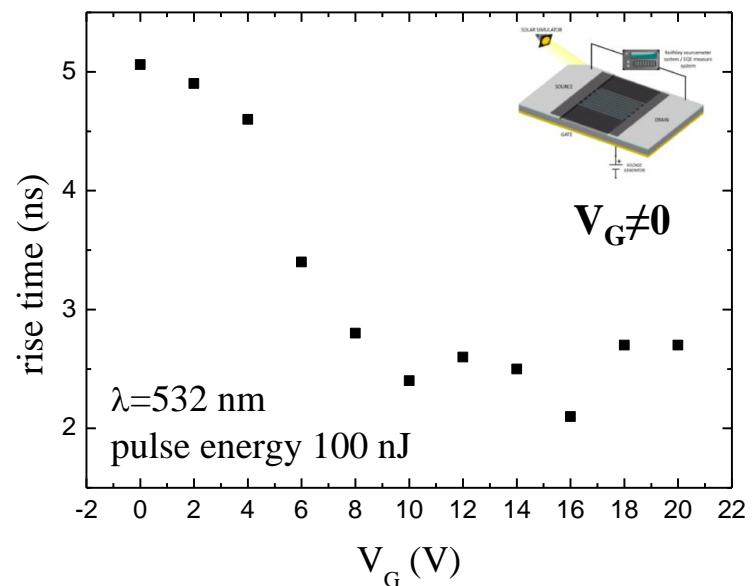
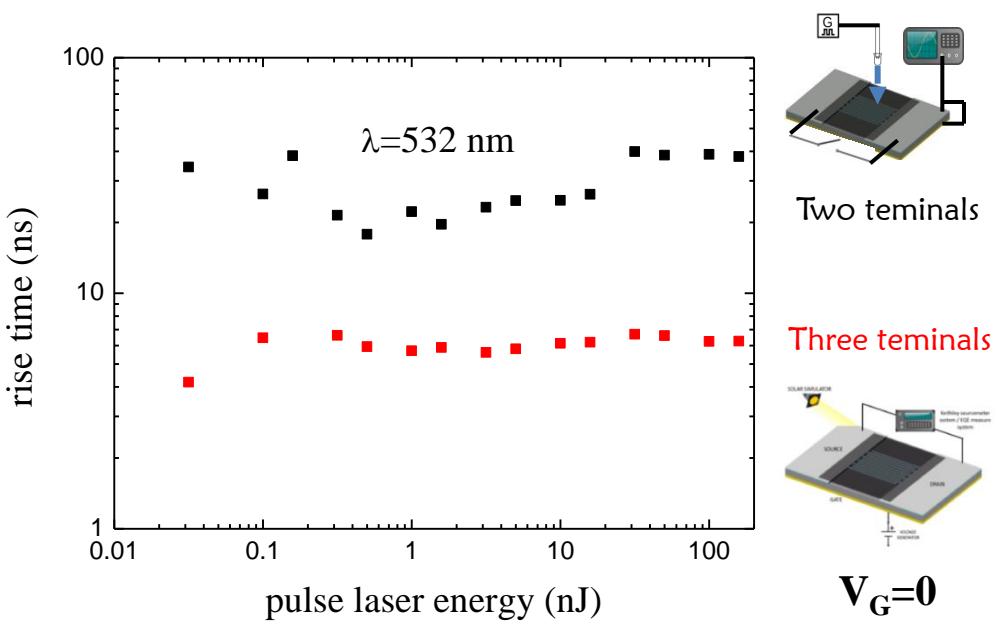
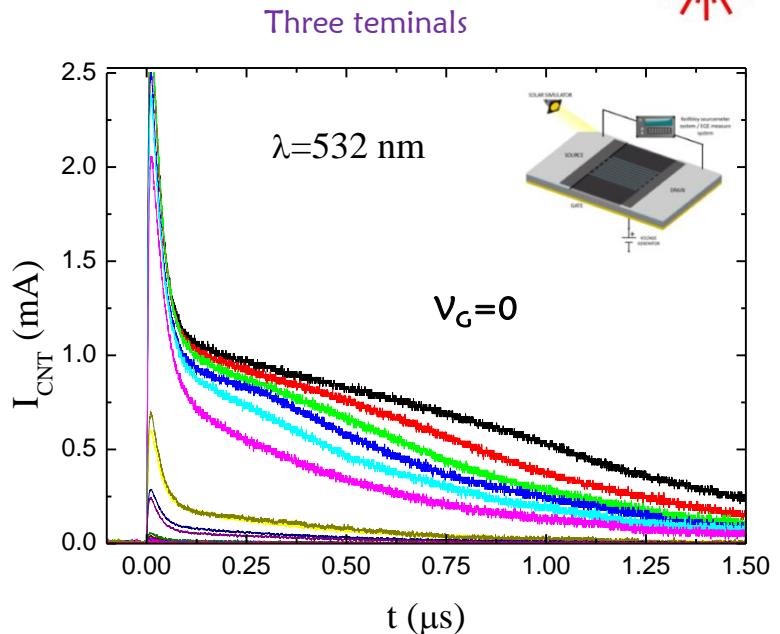
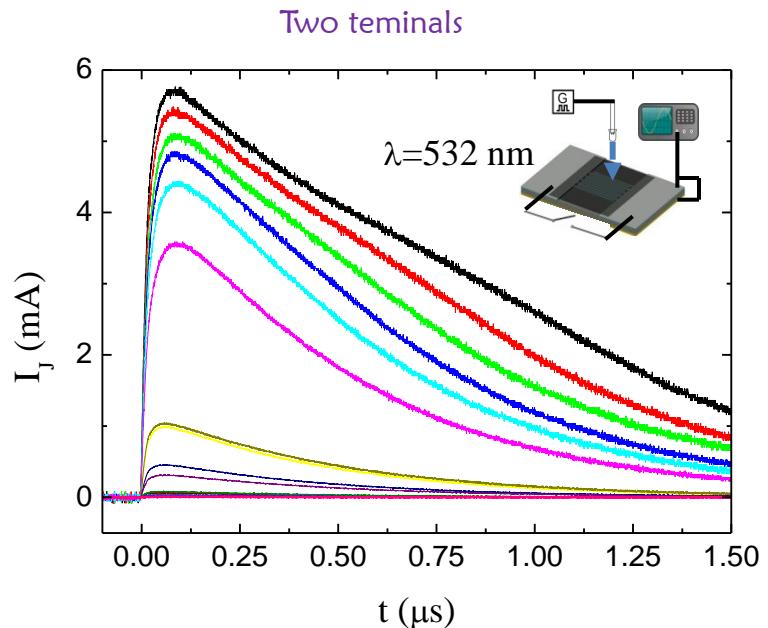
EQE and responsivity increase far above the 2 terminals values



The gate voltage affects the light detection



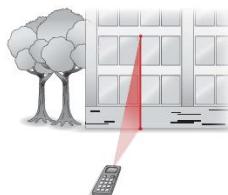
Three terminals vs. two terminals configuration using Pulsed laser 40 fs, 31 pJ-1μJ

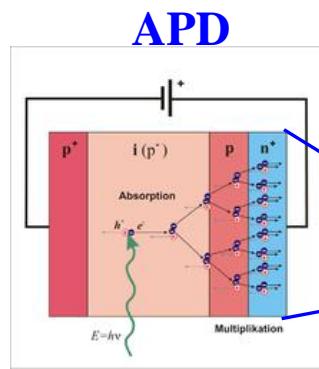
Our photodetector vs. not polarized commercial APD

	Active area	Responsivity	Breakdown voltage	Dark current	Capacitance	Rise time	Spectral range	Gain $V > V_B$ D
Hamamatsu Si APD S12053	0.8 mm ²	0.5 A/W	200 V	0.5 nA	5 pF	1.5 ns	300 nm- 1000 nm	10^5
Osi Optoelectronics HR020 series	0.2 mm ²	0.45 A/W	15 V	0.06 nA	1.8 pF	0.8 ns	400 nm- 1000 nm	
Our SWCNT/Si detectors	9 mm ²	1.2 A/W	20 V	<1 nA	5 nF	3-5 ns	300 nm- 1000 nm	Not meas.

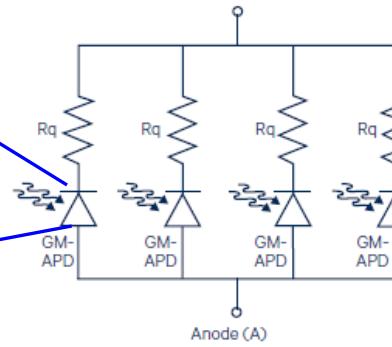
SWCNT junctions as candidates for Avalanche PhotoDetectors (APD)
and possibly for Multi Pixel Photo Counters (MPPC)
for single photon detection



Optical rangefinders



MPPC



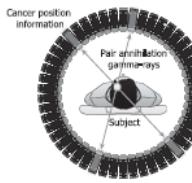
LIDAR



Obstacle detection



Fluorescent measurements



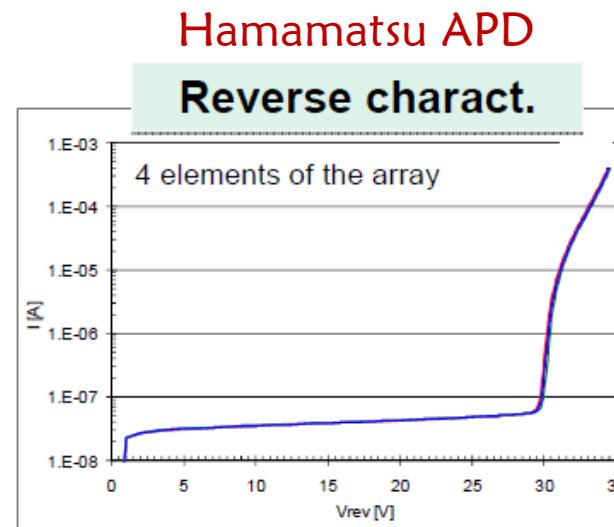
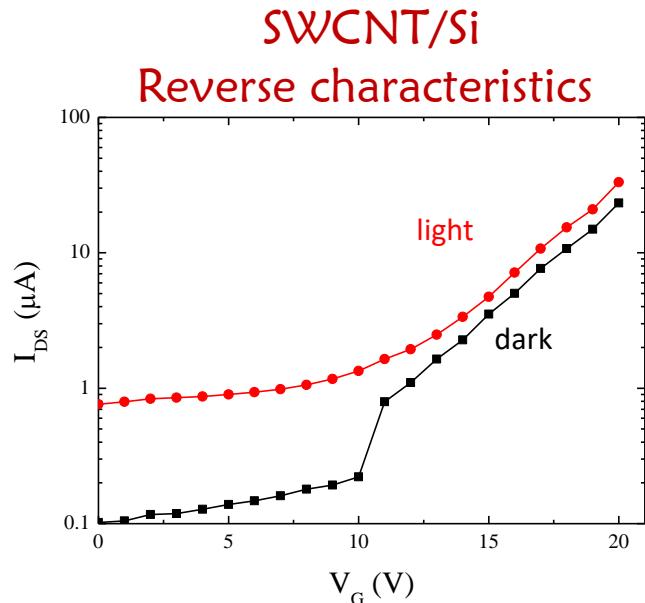
PET-NMR facilities



Cerenkov
telescopes

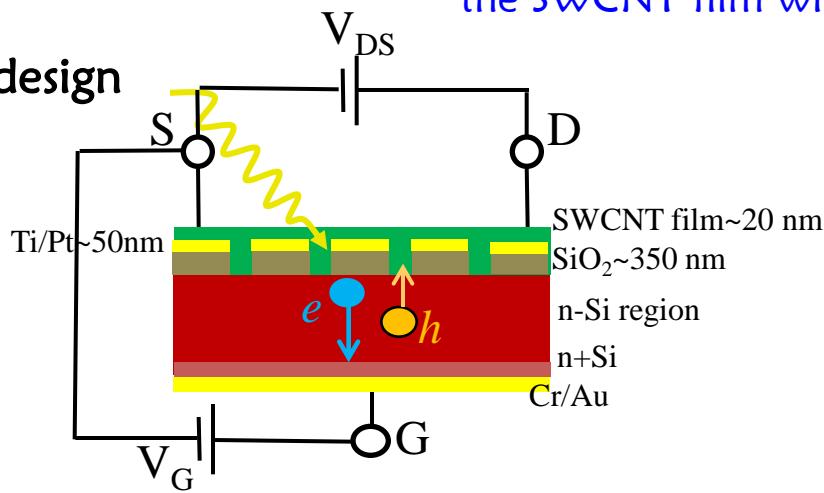
An APD works at a reverse voltage just above the break down.
The photon absorption cause a huge increase of the reverse current

Improvement in the breakdown region is strongly demanded

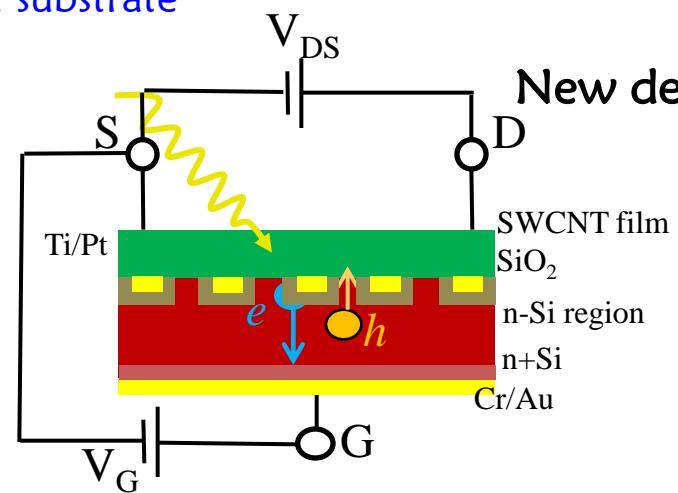


New designed FBK substrates to improve the junction quality through a better contact of the SWCNT film with the Si substrate

Old design



New design



Parameters of interest:

In dark conditions

Voltage breakdown (~ 30 V),
dark current (< 1 nA),
reverse voltage characteristics as a function of temperature and magnetic field.

Schottky or p-n junction

Under light

Quantum efficiency,
responsivity,
detectivity,
response time,
gain
and their dependence on the temperature

SCAPhO Silicon Carbon Avalanche Photodetector

2 years.

Available facilities

INFN Roma2

- SWCNT film fabrication facilities
- Monocromator
- Lamp
- Current/voltage power supply
- Visible wavelengths Femtosecond laser source

INFN Salerno

- Low temperature transport measurement facilities
- Cryostat with 9 T superconducting magnet

Workplan and financial support required

Description	Final date of the action	Equipment	Costs (euro)
New FBK substrates. Electrical and magnetic characterization of the SWCNT thin films.	30-06-2019	Picoammeter; FBK substrates; chemicals	30000
SWCNT film deposition on FBK substrates; junction characterization vs. temperature. Arrangement of existent facility for electrooptical measurements at different temperature.	31-12-2019	Optical fibers, connectors, adaptors, cryogenic supplies	
Electro-optical measurements under light. Quantum efficiency, responsivity, detectivity vs. Temperature. Time response measurements. Optimization of the fabrication parameters.	30-06-2020	Refrigeration liquids, cryogenic feedthrought, mirrors, filters, optical spares	15000
APD electrical circuit; avalanche photodetector response; gain measurement vs. light power, temperature, wavelength.	31-12-2020	Electronics, refrigeration liquids.	